Application/Control No. Applicant(s)/Patent Under Reexamination 10/671,041 CHEN ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 1753 Edna Wong **U.S. PATENT DOCUMENTS Document Number** Date Name Classification Country Code-Number-Kind Code MM-YYYY US-5,831,510 11-1998 Zhang et al. 338/22R Α US-2002/0050914 05-2002 CHIANG et al. 338/22.00R В US-С US-D US-Ε US-F G US-Н US-US-1 US-US-Κ US-L US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Ρ Q R S Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U W

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